

Docket No.: HOK-0270
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Tetsuji Shibata et al.

Application No.: 10/529,861

Confirmation No.: 1482

Filed: March 31, 2005

Art Unit: 1792

For: PLASMA TREATMENT APPARATUS,
METHOD OF PRODUCING REACTION
VESSEL FOR PLASMA GENERATION, AND
PLASMA TREATMENT METHOD

Examiner: Anna M. Crowell

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the non-final Office Action dated October 31, 2007, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.